

# Optical Properties of Single Nanometer-Thick Quantum Wells of Crystalline Silicon

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Single nanometer-thick layers of crystalline silicon (c-Si) confined by amorphous SiO<sub>2</sub> have been prepared by chemical and thermal processing of ELTRAN silicon-on-insulator wafers. The quantum wells of c-Si thus formed have sharp interfaces and exhibit a marked band gap increase with decreasing layer thickness,  $d$ , for  $d < 3$  nm [1]. The room-temperature photoluminescence (PL) from these ultra-thin single wells can be resolved into two bands (see Fig. 1). One band exhibits a strong increase in peak energy with decreasing  $d$ , while the other band remains nearly constant in energy at about 1.8 eV (see Fig. 2). The band gap energy variation predicted from theoretical calculations based on self-consistent full potential linear muffin-tin orbital [2] and first-principles projector-augmented wave [3] methods are also shown in Fig. 2. Comparison with theory shows that the increase in PL peak energy is precisely that predicted for the c-Si energy gap, confirming that this PL band is due to quantum confinement of carriers in the c-Si well. The other PL band is attributed to recombination of confined electron-hole pairs at the c-Si/SiO<sub>2</sub> interface rather than within the quantum well, similar to what has been observed previously in oxidized silicon nanocrystals [3].

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